

IFW



PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q81941

Kenji ITO, et al.

Appln. No.: 10/500,253

Group Art Unit: 2812

Confirmation No.: 8926

Examiner: Maria A. ELVE

Filed: June 25, 2004

For: LASER MATERIAL PROCESSING METHOD

AMENDMENT UNDER 37 C.F.R. § 1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated October 5, 2005, please amend the above-identified application as follows on the accompanying pages.

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